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PATENT

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Case Docket No.: 01P7408US

Date: January 9, 2001

ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231
Box PATENT APPLICATION

Sir:
Transmitted herewith for filing is the patent
application of:

Inventor(s): ATAHVALE et al

For: METHOD FOR DRY ETCHING DEEP TRENCHES IN A SUBSTRATE

This application includes:

24 pages: specification and claims
5 sheets of drawings, formal/X informal
 photographs

Also enclosed is:

X Declaration and Power of Attorney
X Information Disclosure Statement pursuant to 37 CFR 1.56.

The filing fee has been calculated as shown below:

FOR:	(Col. 1) NO. FILED	(Col. 2) NO. EXTRA RATE	OTHER THAN A SMALL ENTITY FEE
BASIC FEE	XXXXXXXX	XXXXXXXXXX	XXXXX \$ 690.
TOTAL CLAIMS	25- 20 =	5	x 18.= \$ 90.
INDEP CLAIMS	3- 3 =	0	x 78.= \$ 0.
* MULTIPLE DEPENDENT CLAIM PRESENTED			+260.= \$ 780.
			TOTAL \$ 780.

X Please charge my Deposit Account No. 19-2179 in the amount of \$ 780.00. A duplicate copy of this sheet is enclosed.
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X Any patent application processing fees under 37 CFR 1.17.
X Any filing fees under 37 CFR 1.16 for presentation of extra claims.

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